

	Service	Rate (\$/hour)	cap per user (\$)	cap per group (\$)	min booking (min)
Equipment					
	Ion Beam Etching	60	1500	3000	60
	Reactive Ion Etching	60	1500	3000	60
	E-beam deposition	60	1500	3000	60
	Bench Top SEM	60	1500	3000	15
	Tube furnaces	30	1000	2000	60
	MW-CVD	30	1000	2000	60
	Maskless Litho	30	1000	2000	15
	Spin Coating	30	1000	2000	15
Materials					
	Gold	10/nm	per person		
	SF6	1000/year	per group	for RIE usage	
Staff					
	Training/Machine usage	90	min 2 hours		
	Non-ANFF Tool Usage	90			
ALL CHARGES VARIABLE DEPENDING ON PROJECT REQUIREMENTS					